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PATENT APPLICATION

Attorney Docket:

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Laura Wills Mirkarimi, et al

Serial No.: 10/692772

Filed: October 24, 2003

For: Method For Etching Smooth  
Sidewalls in III-V Based  
Compounds For  
Electro-Optical Devices

Group Art Unit: 1765

Examiner: Lan Vinh

**AMENDMENT**Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated 11/15/2005, in the above-identified patent application, Applicant submits the following Amendments and Remarks. An RCE is enclosed with this response. Applicant respectfully requests that the following amendments be entered into the above-identified application and that the Examiner reconsider the grounds for rejection stated in the Office Action.

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